L Number	Hits	Search Text	DB	Time stamp
1	243	29/25.35.ccls. and SAW	USPAT;	2004/08/10 12:05
1	5		JPO;	
			DERWENT	
2	l 0	(29/25.35.ccls. and SAW) and (alpha adj tantalum)	USPAT;	2004/08/10 12:06
-		, and the same of	JPO;	
			DERWENT	
3	0	29/25.35 and (alpha adj tantalum)	USPAT;	2004/08/10 12:05
		\	JPO;	
			DERWENT	
4	346480	(SAW) or (surface adj acoustic adj wave) or transducer	USPAT;	2004/08/10 12:05
			JPO;	
			DERWENT	
5	2093	29/25.35.ccls.	USPAT;	2004/08/10 12:05
	1		JPO;	
İ			DERWENT	
6	768	((SAW) or (surface adj acoustic adj wave) or transducer) and	USPAT;	2004/08/10 12:05
	1	29/25.35.ccls.	JPO;	
1	1		DERWENT	
7	0	(((SAW) or (surface adj acoustic adj wave) or transducer) and	USPAT;	2004/08/10 12:06
1		29/25.35.ccls.) and (alpha adj tantalum)	JPO;	
1			DERWENT	
-	125915	sputtering	USPAT;	2004/01/09 09:04
			JPO;	
1			DERWENT	
-	0	sputtering with (iner adj gas) with nitrogen	USPAT;	2004/01/08 16:23
			JPO;	
]	[DERWENT	
-	369	sputtering with (inert adj gas) with nitrogen	USPAT;	2004/01/08 16:24
]			JPO;	
į i			DERWENT	
-	4	(sputtering with (inert adj gas) with nitrogen) and saw	USPAT;	2004/01/08 16:24
			JPO;	
	_	and the single state of the set and the second state of the second	DERWENT	0004/04/00 40 00
-	7	sputtering with (inert adj gas) with (nitrogen or argon) and	USPAT;	2004/01/08 16:32
		SAW	JPO;	
	4700	204/102 15 colo	DERWENT	2004/04/00 40:00
-	1790	204/192.15.ccls.	USPAT;	2004/01/08 16:32
			JPO;	
[57285	tantalum	DERWENT USPAT;	2004/01/08 16:32
ا ا	5/205	tantalum ,		2004/01/08 10:32
			JPO; DERWENT	
_	313	204/192.15.ccls. and tantalum	USPAT:	2004/01/08 16:32
-	313	207/102.10.003. and tantalum	JPO;	2004/01/00 10:32
			DERWENT	
_	o	a-tnatalum	USPAT;	2004/01/08 16:32
			JPO;	250-70 1700 10.52
			DERWENT	
-	1	a-tantalum	USPAT;	2004/01/08 16:33
	' I		JPO;	
			DERWENT	
_	81	alpha adj tantalum	USPAT;	2004/08/10 12:04
			JPO:	_30 1100110 12.04
			DERWENT	
-	9	204/192.15.ccls. and (alpha adj tantalum)	USPAT;	2004/01/08 16:33
	_		JPO:	
1		•	DERWENT	
-	10	sputtering with (alpha adj tantalum) with (nitrogen or argon)	USPAT;	2004/01/09 09:49
		, , , , , , , , , , , , , , , , , , , ,	JPO;	
			DERWENT	
-	5	("4340834" "5221449" "5281485" "5847486"	USPAT	2004/01/08 16:34
l		"5850167").PN.		
-	1	IDT with (alpha adj tantalum)	USPAT;	2004/01/08 16:42
ŀ	i	• • • •	JPO;	
			DERWENT	

-	3	interdigital with (alpha adj tantalum)	USPAT;	2004/01/08 16:42
			JPO; DERWENT	
	00	-lo stro do with (olabo odi tantalum)	USPAT;	2004/01/08 16:40
-	26	electrode with (alpha adj tantalum)	JPO;	2004/01/08 10.40
			DERWENT	
	6	("4251326" "5162690" "5221449" "5274482" "6218763"	USPAT	2004/01/08 16:40
1	8	"6127769").PN.	00171	200-70 1700 10.40
1_	1	(("4251326" "5162690" "5221449" "5274482" "6218763"	USPAT;	2004/01/08 16:41
	•	"6127769").PN.) and IDT	JPO;	
		, ,	DERWENT	
-	0	((("4251326" "5162690" "5221449" "5274482" "6218763"	USPAT;	2004/01/08 16:42
		"6127769").PN.) and IDT) and (alpha adj tantalum)	JPO;	
			DERWENT	
-	4	(interdigital with tantalum) and (alpha adj tantalum)	USPAT;	2004/01/08 16:42
			JPO;	
	45	intendiciant with Acatalyan	DERWENT	2004/04/09 46:42
-	15	interdigital with tantalum	USPAT;	2004/01/08 16:43
			JPO; DERWENT	
_	5	29/592.1,594,609.1.ccls. and IDT	USPAT;	2004/01/08 16:46
1	"	20/002.1,004,000.1.006. and 101	JPO:	230-701700 10.40
			DERWENT	ļ
-	55	29/\$.ccls. and IDT	USPAT;	2004/01/08 16:46
			JPO;	
			DERWENT	
-	13	29/592.1,594,609.1.ccls. and interdigital	USPAT;	2004/01/08 16:46
			JPO;	
			DERWENT	
-	143	29/\$.ccls. and interdigital	USPAT;	2004/01/08 16:46
			JPO;	
	0	(alpha adj tantalum) and (29/\$.ccls. and interdigital)	DERWENT USPAT;	2004/01/08 16:46
-		(alpha adj taritalum) and (25/\$.ccis. and interdigital)	JPO;	2004/01/00 10.40
			DERWENT	
_	4	(alpha adj tantalum) and interdigit\$2	USPAT;	2004/01/08 16:48
			JPO;	
			DERWENT	
-	111651	low with resist\$3	USPAT;	2004/01/09 09:04
			JPO;	
	4004	1	DERWENT	0004/04/00 00 05
-	4324	low adj resist\$3	USPAT;	2004/01/09 09:05
			JPO; DERWENT	
1_	12280	interdigital wtih taltalum	USPAT;	2004/01/09 09:06
1	12200		JPO;	2007/01/03 03.00
		<u>,</u>	DERWENT	
-	11	(low adj resist\$3) and (interdigital wtih taltalum)	USPAT;	2004/01/09 09:05
			JPO;	
ļ			DERWENT	
-	1	(interdigital wtih taltalum) same (low adj resist\$3)	USPAT;	2004/01/09 09:06
			JPO;	
			DERWENT	0004/04/00 10 01
-	42	(interdigital wtih tantalum) same (low adj resist\$3)	USPAT;	2004/01/09 10:21
			JPO;	
1_	o	(interdigital near tantalum) same (low adj resist\$3)	DERWENT USPAT;	2004/01/09 09:08
1	"	(interdigital fieal taritaluli) sallie (low au) lesist\$3)	JPO:	2007/01/08 08.00
1			DERWENT	
-	o	(interdigital same tantalum) same (low adj resist\$3)	USPAT;	2004/01/09 09:08
	[, , , , , , , , , , , , , , , , , , , ,	JPO;	
			DERWENT	
-	0	(interdigital with tantalum) same (low adj resist\$3)	USPAT;	2004/01/09 09:09
			JPO;	
	_ [Manufal area and the second se	DERWENT	00046450
-	0	(tantalum same (low adj resist\$3)) and interdigital	USPAT;	2004/01/09 09:41
			JPO;	
			DERWENT	L

-	41	tantalum same (low adj resist\$3)	USPAT; JPO;	2004/01/09 09:35
			DERWENT	
-	0	(alpha adj tantalum) same (low adj resist\$3)	USPAT;	2004/01/09 10:24
			JPO;	
			DERWENT	
_	2	((alpha adj tantalum) same ((low or reduce\$1) adj resist\$5))	USPAT;	2004/01/09 09:44
1	_	and interdigital	JPO;	
		i and interdigital	DERWENT	
	1 4-	(- -		2004/04/00 00:44
-	17	(alpha adj tantalum) same ((low or reduce\$1) adj resist\$5)	USPAT;	2004/01/09 09:44
			JPO;	
	1		DERWENT	
-	1	((alpha adj tantalum) same ((low or reduce\$1) adj resist\$5))	USPAT;	2004/01/09 09:44
		and SAW	JPO;	
			DERWENT	
_	852	(interdigital wtih tantalum) same (low adj resist\$5)	USPAT;	2004/01/09 09:48
] -	002	(interdigital will taritalism) same (low adjitesistyo)		2004/01/00 00:40
			JPO;	
			DERWENT	
1 -	327	sputtering with (tantalum) with (nitrogen or argon)	USPAT;	2004/01/15 09:12
			JPO;	
			DERWENT	
	30	((interdigital wtih tantalum) same (low adj resist\$5)) and	USPAT;	2004/01/09 10:07
		(sputtering with (tantalum) with (nitrogen or argon))	JPO;	
		(sputtering with (tantaitin) with (hitrogen of argon))	DERWENT	
	4700			0004/04/00 40.00
-	4793	sputtering same (distance or space or distance) same (target	USPAT;	2004/01/09 10:08
		or substrate)	JPO;	
1			DERWENT	
-	4793	sputtering same (space or distance) same (target or substrate)	USPAT;	2004/01/09 10:08
1			JPO;	
			DERWENT	
	57	(sputtering with tantalum) same (space or distance) same	USPAT;	2004/01/12 09:12
-	37			2004/01/12 09.12
		(target or substrate)	JPO;	
		[DERWENT	
-	36	(sputtering with tantalum) same (pressure) same (power)	USPAT;	2004/01/09 10:17
		same temperature	JPO;	i
			DERWENT	
_	0	(interdigital wtih tantalum) same (low adj resist\$3) same	USPAT;	2004/01/09 10:25
	_	reflector	JPO;	
			DERWENT	
	1055	(interdigital wtih tantalum) same reflector	USPAT;	2004/01/09 10:23
-	1000	(interdigital with tantalum) same reflector		2004/01/09 10.23
			JPO;	
			DERWENT	
-	436	((interdigital wtih tantalum) same reflector) and saw	USPAT;	2004/01/09 10:22
			JPO;	
			DERWENT	
-	1083	(reflector wtih tantalum) same SAW	USPAT;	2004/01/09 10:24
	1	,	JPO;	
			DERWENT	
	81	alpha adj tantalum		2004/01/09 10:24
-	j °'	aipha auj tahtalum	USPAT;	2004/01/08 10.24
			JPO;	
	!		DERWENT	
-	1	((reflector wtih tantalum) same SAW) and (alpha adj tantalum)	USPAT;	2004/01/09 10:24
			JPO;	
	1		DERWENT	
-	1	(alpha adj tantalum) with reflector	USPAT;	2004/01/09 10:24
	· ·	The state of the s	JPO;	
			DERWENT	
	1055	(interdigital utilit tental um) some reflecter		2004/04/00 40:25
-	1055	(interdigital wtih tantalum) same reflector	USPAT;	2004/01/09 10:25
	!		JPO;	
			DERWENT	
-] 1	(interdigital wtih tantalum) same (low adj resist\$5) same	USPAT;	2004/01/09 10:25
		reflector	JPO;	
			DERWENT	
_	o	tantalum same (low adj resist\$5) same reflector	USPAT;	2004/01/09 10:26
		Tarmarani daine from day rediction daine relicotor	JPO;	200-70 1700 10.20
		L	DERWENT	l !

-	7	(tantalum same reflector) and saw	USPAT; JPO;	2004/01/09 10:26
			DERWENT	
1_	142	tantalum same reflector	USPAT:	2004/01/09 10:27
	1		JPO;	
			DERWENT	
-	9	(sputtering with tantalum) same (space or distance) same	USPAT;	2004/01/12 09:39
		(target or substrate) same thickness	JPO;	
			DERWENT	
-	4	saw and (reflector\$1 with tantalum)	USPAT;	2004/01/12 09:40
			JPO;	
	7	anu and (reflector\$4 same tantalum)	DERWENT USPAT;	2004/01/12 09:42
-		saw and (reflector\$1 same tantalum)	JPO;	2004/01/12 05.42
			DERWENT	
_	5	IDT and (reflector\$1 same tantalum)	USPAT;	2004/01/12 09:42
			JPO:	
1			DERWENT	
-	15	(US-6144057-\$ or US-5281485-\$ or US-5221449-\$ or	USPAT; JPO	2004/01/15 08:51
		US-6226171-\$ or US-4410867-\$ or US-5850167-\$ or		
		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or		
		US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or		
		US-6191031-\$ or US-6154105-\$).did. or (JP-04186815-\$).did.	LICDAT.	2004/01/15 09:34
-	3	((US-6144057-\$ or US-5281485-\$ or US-5221449-\$ or US-6226171-\$ or US-4410867-\$ or US-5850167-\$ or	USPAT; JPO:	2004/01/15 09.54
		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or	DERWENT	
		US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or	O E A TOP E A	
		US-6191031-\$ or US-6154105-\$).did. or		
		(JP-04186815-\$).did.) and piezoelectric		
-	18	sputtering with (alpha adj tantalum)	USPAT;	2004/01/15 09:00
			JPO;	
		min-no al antaine with fall-hand all tantal was	DERWENT	2004/04/45 00:00
-	3	piezoelectric with (alpha adj tantalum)	USPAT; JPO;	2004/01/15 09:00
			DERWENT	
_	186	(vapor daj deposition) with (tantalum) with (nitrogen or argon)	USPAT;	2004/01/15 09:14
	1	(,,,,,,,	JPO;	
			DERWENT	
-	2	(vapor daj deposition) with (alpha adj tantalum) with (nitrogen	USPAT;	2004/01/15 09:13
		or argon)	JPO;	
	600640		DERWENT	2004/04/45 00:42
-	699640	vapor daj deposition	USPAT; JPO;	2004/01/15 09:13
			DERWENT	
_	1	(vapor adj deposition) with (alpha adj tantalum) with (nitrogen	USPAT;	2004/01/15 09:14
		or argon)	JPO;	
		- ,	DERWENT	
-	58	(vapor adj deposition) with (tantalum) with (nitrogen or argon)	USPAT;	2004/01/15 09:14
			JPO;	
		(vanor adi danggitian) with matel with piercalectric with	DERWENT	2004/01/45 00:45
-	0	(vapor adj deposition) with metal with piezoelectric with (nitrogen or argon)	USPAT; JPO;	2004/01/15 09:15
		(macgon or argon)	DERWENT	
-	12	((vapor adj deposition) with metal with piezoelectric) and saw	USPAT;	2004/01/15 09:15
	_		JPO;	
			DERWENT	
-	1	((US-6144057-\$ or US-5281485-\$ or US-5221449-\$ or	USPAT;	2004/01/15 09:17
		US-6226171-\$ or US-4410867-\$ or US-5850167-\$ or	JPO;	
		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or	DERWENT	
		US-6191031-\$ or US-6154105-\$).did. or		
		(JP-04186815-\$).did.) and (vapor adj deposition)		
-	93	(vapor adj deposition) with metal with piezoelectric	USPAT;	2004/01/15 09:19
			JPO;	
			DERWENT	

		·		
-	8	((US-6144057-\$ or US-5281485-\$ or US-5221449-\$ or	USPAT;	2004/01/15 09:36
		ÜS-6226171-\$ or US-4410867-\$ or US-5850167-\$ or	JPO;	
		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or	DERWENT	
		US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or		
		US-6191031-\$ or US-6154105-\$).did. or		
		(JP-04186815-\$).did.) and tungsten		
-	6	((US-6144057-\$ or US-5281485-\$ or US-5221449-\$ or	USPAT;	2004/01/15 09:39
		US-6226171-\$ or US-4410867-\$ or US-5850167-\$ or	JPO;	
		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or	DERWENT	
		US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or		
		US-6191031-\$ or US-6154105-\$).did. or		
	ľ	(JP-04186815-\$).did.) and (tungsten with tantalum)		
-	2		USPAT;	2004/01/15 09:40
		US-6226171-\$ or US-4410867-\$ or US-5850167-\$ or	JPO;	
1		US-5140403-\$ or US-6088462-\$ or US-6110598-\$ or	DERWENT	
		US-5281554-\$ or US-6375312-\$ or US-5714268-\$ or		
1		US-6191031-\$ or US-6154105-\$).did. or		
		(JP-04186815-\$).did.) and (tungsten with titanium)		
_	666		USPAT;	2004/01/15 09:40
-	000	Saw and (tungsten with titalium)	JPO;	2004/01/10 00:40
	•		DERWENT	
	0	now and (tungaton with titanium) with hilayan	USPAT;	2004/01/15 09:41
-	"	saw and (tungsten with titanium) with bilayer		2004/01/15 09.41
	i		JPO;	
			DERWENT	0004/04/45 00 44
-	0	saw and ((tungsten with titanium) with bilayer)	USPAT;	2004/01/15 09:41
			JPO;	
			DERWENT	
-	0	saw and ((tungsten with titanium) with bi-layer)	USPAT;	2004/01/15 09:41
			JPO;	
			DERWENT	
-	0	saw and ((tungsten same titanium) with bi-layer)	USPAT;	2004/01/15 09:41
			JPO;	
			DERWENT	
-	728	saw and (tungsten same titanium)	USPAT;	2004/01/15 09:41
		,	JPO;	
			DERWENT	
	257	saw and ((tungsten same titanium) with tantalum)	USPAT;	2004/01/15 09:42
		Can and ((angoton came manner) man tamasany	JPO;	
			DERWENT	
_	255	saw and ((tungsten with titanium) with tantalum)	USPAT;	2004/01/15 09:45
		Con the (tensor than the tensor)	JPO;	
			DERWENT	
_	11	saw and ((tungsten with titanium) with tantalum with	USPAT;	2004/01/15 09:45
1	''	piezoelectric)	JPO;	2004/01/10 00.40
1		piozoolootiloj	DERWENT	
[_ i	170	piezoelectric and ((metal\$3 adj layer) same titanium)	USPAT;	2004/04/29 11:48
-	1/0	piezoelectric and ((metaipo auj layer) same titamum)		2007/04/23 11.40
]			JPO;	
	4.0	(nigraplostric and ((motal©2 adi lever) same titerium)) and	DERWENT	2004/04/20 42:40
-	18	(piezoelectric and ((metal\$3 adj layer) same titanium)) and	USPAT;	2004/04/29 12:49
		SAW	JPO;	
			DERWENT	0004/04/00
-	1	"5909156".PN.	USPAT	2004/04/29 11:43
-	5	("4445066" "4775814" "5144185" "5773917"	USPAT	2004/04/29 11:46
		"5909156").PN.		
-	0	(("4445066" "4775814" "5144185" "5773917"	USPAT;	2004/04/29 11:48
		"5909156").PN.) and ((metal\$3 adj layer) same titanium)	JPO;	
			DERWENT	
[-	2	(("4445066" "4775814" "5144185" "5773917"	USPAT;	2004/04/29 11:48
		"5909156").PN.) and piezoelectric and titanium	JPO;	
			DERWENT	
-	1	(US-6259185-\$).did.	USPAT	2004/04/29 12:43
_	Ó	((US-6259185-\$).did.) and (shear same wave)	USPAT;	2004/04/29 12:44
		1/1	JPO;	
			DERWENT	
<u> </u>	0	((US-6259185-\$).did.) and shear	USPAT;	2004/04/29 12:44
		(100 0200 100-w).did.) dild siledi	JPO;	2007/07/20 12:44
			DERWENT	
	L	<u> </u>	PEKAAGIAI	L

			·	
-	1	((US-6259185-\$).did.) and wave	USPAT;	2004/04/29 12:48
			JPO;	
			DERWENT	
-	0	((US-6259185-\$).did.) and horizon\$3	USPAT;	2004/04/29 12:48
			JPO;	
			DERWENT	
-	3	(piezoelectric and ((metal\$3 adj layer) same titanium)) and	USPAT;	2004/04/29 12:49
		(shear same wave)	JPO;	
			DERWENT	
-	71	shear adj horizontal adj wave	USPAT;	2004/04/29 12:57
			JPO;	
	Ì		DERWENT	
-	3	(shear adj horizontal adj wave) same SAW	USPAT;	2004/04/29 12:57
			JPO;	
			DERWENT	
-	22	(shear adj horizontal adj wave) and SAW	USPAT;	2004/04/29 12:51
			JPO;	
			DERWENT	
-	5390	surface adj acoustic adj wave adj device	USPAT;	2004/04/29 12:58
			JPO;	
			DERWENT	
-	17	(shear adj horizontal adj wave) and (surface adj acoustic adj	USPAT;	2004/04/29 12:59
		wave adj device)	JPO;	
			DERWENT	
] -	0	(piezoelectric and ((metal\$3 adj layer) same titanium)) and	USPAT;	2004/04/29 12:59
1		((shear adj horizontal adj wave) and (surface adj acoustic adj	JPO;	
İ		wave adj device))	DERWENT	
-	17	((shear adj horizontal adj wave) and (surface adj acoustic adj	USPAT;	2004/04/29 12:59
1		wave adj device)) and @ay<19990902	JPO;	
Ì			DERWENT	
-	6	((shear adj horizontal adj wave) and (surface adj acoustic adj	USPAT;	2004/04/29 13:02
		wave adj device)) and @ad<19990902	JPO;	
		(HE770047H HE044047H HE047400H HE0E4E07H HE0C5005H	DERWENT	0004/04/00 40 61
-	6	("5773917" "5844347" "5847486" "5854527" "5905325"	USPAT	2004/04/29 13:01
		"5909156").PN.	LICEAT	0004/04/00 46 00
-	0	(shear adj horizontal adj wave) and (("5773917" "5844347"	USPAT;	2004/04/29 13:02
		"5847486" "5854527" "5905325" "5909156").PN.)	JPO;	
	اما	formamorantia non conner	DERWENT	0004/04/00 44:40
-	1	ferromagentic near copper	USPAT;	2004/04/30 11:42
			JPO;	
	4	forramagantia nagr (conner or C:-)	DERWENT	2004/04/20 44:40
-	1	ferromagentic near (copper or Cu)	USPAT;	2004/04/30 11:42
			JPO;	
	0	(forromagantia adi matarial) noce (conner es Cu)	DERWENT	2004/04/20 44:40
_	"	(ferromagentic adj material) near (copper or Cu)	USPAT;	2004/04/30 11:42
•		•	JPO;	
			DERWENT	